



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 17, 2025

IGI Report Number **LG752559831**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.40 X 6.33 X 4.58 MM**

GRADING RESULTS

Carat Weight **1.56 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

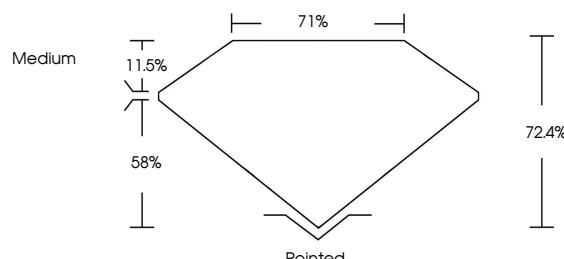
Inscription(s) **IGI LG752559831**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

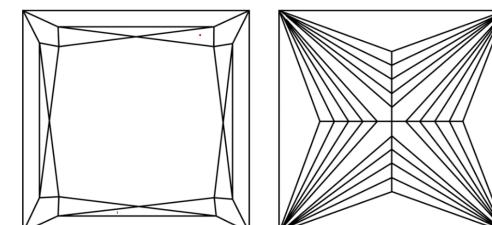
Type Ila

LG752559831
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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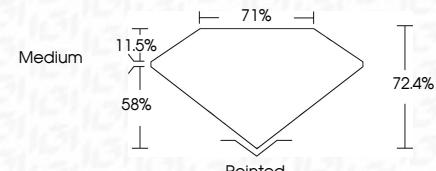
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Sample Image Used



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December 17, 2025	IGI Report No. LG752559831	1.56 CARAT	E	VVS 2	EXCELLENT	72.4%	71%	Medium	Pointed	EXCELLENT	EXCELLENT	None
		Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence
		6.40 X 6.33 X 4.58 MM		VVS 1-2	VS 1-2	SI 1-2	I 1-3					
				Very Very Slightly Included	Very Slightly Included	Slightly Included	Included					
				Internally Flawless	Flawless							



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